

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q77851

Hiroo TAKIZAWA, et al.

Appln. No.: 10/678,301

Group Art Unit: 1756

Confirmation No.: 4148

Examiner: Martin J. ANGEBRANNDT

Filed: October 6, 2003

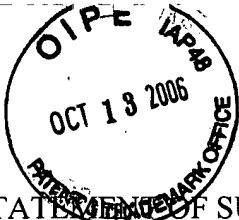
For: NON-RESONANT TWO-PHOTON ABSORBING MATERIAL, NON-RESONANT TWO-PHOTON EMITTING MATERIAL, AND METHOD FOR INDUCING ABSORPTION OR GENERATING EMISSION OF NON-RESONANT TWO PHOTONS BY USING THE MATERIAL

STATEMENT OF SUBSTANCE OF INTERVIEW

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please review and enter the following remarks summarizing the telephone interview
conducted on April 11, 2006:

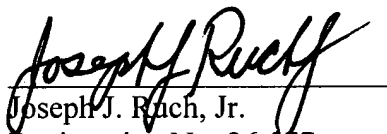


STATEMENT OF SUBSTANCE OF INTERVIEW
U.S. Application No. 10/678,301
Attorney Docket No. Q77851

REMARKS

An Examiner's Interview Summary Record (PTO-413) was attached to the Non-Final Office Action mailed April 13, 2006. The PTO-413 contains a full and accurate representation of the contents of the interview.

Respectfully submitted,


Joseph J. Ruch, Jr.
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WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: October 13, 2006